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NATURE OF CONVEYANCE:	ASSIGNMENT

### **CONVEYING PARTY DATA**

Name	Execution Date
Tadahiro Ishizaka	12/17/2007
Kentaro Asakura	12/25/2007
Masanao Ando	12/17/2007
Toshio Hasegawa	12/17/2007

#### **RECEIVING PARTY DATA**

Name:	Tokyo Electron Limited
Street Address:	TPS Broadcast Center, 3-6 Akasaka 5-chome
City:	Minato-ku, Tokyo
State/Country:	JAPAN
Postal Code:	107-8481

#### PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	11968369

### **CORRESPONDENCE DATA**

Fax Number: (480)539-2100

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

Phone: 4805392106

Email: audunn.ludviksson@us.tel.com

Correspondent Name: Audunn Ludviksson
Address Line 1: 4350 W Chandler Blvd

Address Line 2: Suite 10

Address Line 4: Chandler, ARIZONA 85226

ATTORNEY DOCKET NUMBER: TTCA-233

NAME OF SUBMITTER: Audunn Ludviksson

Total Attachments: 4

PATENT REEL: 020307 FRAME: 0089

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PATENT REEL: 020307 FRAME: 0090

# **ASSIGNMENT OF INVENTION AND PATENTS THEREON**

For valuable consideration, I/we, Tadahiro Ishizaka, Kentaro Asakura, Masanao Ando, and Toshio Hasegawa, hereby assign to Tokyo Electron Limited, a Corporation of Japan and having a place of business at TBS Broadcast Center, 3-6 Akasaka 5-chome, Minato-Ku, Tokyo 107-8481 JAPAN, and its successors and assigns (collectively hereinafter called "the Assignee"), my entire right, title and interest throughout the world in the inventions and improvements which are subject of an application of United States Patent entitled METHOD FOR IN-SITU REFURBISHING A CERAMIC SUBSTRATE HOLDER, and filed on 1/2/2008as Patent Application No.11/968369 preparatory to obtaining Letters Patent of the United States therefore, this assignment including said application, any continuation, division or continuation-in-part thereof and/or substituted therefore, any and all United States and foreign patents, utility models, and design registrations granted for any of said inventions or improvements, and the right to claim priority based on the filing date of said application under the International Convention for the Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all other treaties of like purposes; and authorize the Assignee to apply in all countries in my name or in its own name for patents, utility models, and design registrations and like rights of exclusion and for inventors' certificates for said inventions and improvements; and agree for myself and my heirs, legal representatives and assigns, without further compensation to perform such lawful acts and to sign such further applications, assignments, Preliminary Statements and other lawful documents as the Assignee may reasonably request to effectuate fully this Assignment. I hereby authorize and request that any one of the attorneys or agents of Tokyo Electron U.S. Holdings, 2400 Grove Boulevard, Austin, Texas 78741, to insert herein the filing date and application serial number of said application when known.

Inventor's Signature:	Todalina	lahjaho	Date:	Dec. / 17/'07
Full Name:	Tadahiro	Ishizaka		1
Residence:	305 Beryl	Way, Watervlie	et, NY 12189,	US
Inventor's Signature:			Date:	
Full Name:	Kentaro A	Asakura		
Residence:	2330-6 Sh	inohara, Kai-Si	ni, Yamanash	<u>i-ken, Japan, 400-0115</u>

Inventor's Signatu	ire: Masm and	Date: Dec / 17 / 2007
Full Name:	Masanao Ando	
Residence:	7 Fox Hollow, Rensselaer, NY	/ 12144, US
l	re: Joshiv Hasegana	n. In I'm I'm
inventor's Signatu	re: JOHNS HUSEYUNG	Date: Vec./ (1/ 0)
Full Name:	Toshio Hasegawa	
Residence:	59 Mansion Blvd, Apt. J. Delm	ar. NY 12054. US

PATENT REEL: 020307 FRAME: 0092

## ASSIGNMENT OF INVENTION AND PATENTS THEREON

For valuable consideration, I/we, Tadahiro Ishizaka, Kentaro Asakura, Masanao Ando, and Toshio Hasegawa, hereby assign to Tokyo Electron Limited, a Corporation of Japan and having a place of business at TBS Broadcast Center, 3-6 Akasaka 5-chome, Minato-Ku, Tokyo 107-8481 JAPAN, and its successors and assigns (collectively hereinafter called "the Assignee"), my entire right, title and interest throughout the world in the inventions and improvements which are subject of an application of United States Patent entitled METHOD FOR IN-SITU REFURBISHING A CERAMIC SUBSTRATE HOLDER, and filed on 1/2/2008 as Patent Application No. 11 / 968369 preparatory to obtaining Letters Patent of the United States therefore, this assignment including said application, any continuation, division or continuation-in-part thereof and/or substituted therefore, any and all United States and foreign patents, utility models, and design registrations granted for any of said inventions or improvements, and the right to claim priority based on the filing date of said application under the International Convention for the Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all other treaties of like purposes; and authorize the Assignee to apply in all countries in my name or in its own name for patents, utility models, and design registrations and like rights of exclusion and for inventors' certificates for said inventions and improvements: and agree for myself and my heirs, legal representatives and assigns, without further compensation to perform such lawful acts and to sign such further applications, assignments, Preliminary Statements and other lawful documents as the Assignee may reasonably request to effectuate fully this Assignment. I hereby authorize and request that any one of the attorneys or agents of Tokyo Electron U.S. Holdings, 2400 Grove Boulevard, Austin, Texas 78741, to insert herein the filing date and application serial number of said application when known.

Inventor's Signature: _	Date:
Full Name:	Tadahiro Ishizaka
Residence:	305 Beryl Way, Watervliet, NY 12189, US
Inventor's Signature: _	Hentaro Asglaura Date: 12/25/2007
Full Name:	Kentaro Asakura
Residence:	2330-6 Shinohara, Kai-Shi, Yamanashi-ken, Japan, 400-0115

Inventor's Signature:		Date:	
Full Name:	Masanao Ando		
Residence:	7 Fox Hollow, Rensselaer, NY 12144, US		
Inventor's Signature: _		Date:	
Full Name:	Toshio Hasegawa		
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